#3/4-26-52

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Rule 53(b) Divisional Application of:

Hisao SHIGEMATSU et al.

Serial No.: Divisional of 09/191,543

Group Art Unit: 2815 (prior)

Filed: **March 8, 2002**

Examiner: Bradley W. Baumeister (prior)

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

- Commissioner for Patents Washington, D.C. 20231

March 8, 2002

Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were made of record in parent application Serial No. 09/191,543.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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